



PATENT
Atty. Dkt. AMAT/7729/TCG/EPI/RKK

IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Singh, et al.

Serial No.: 10/688,797

Filed: October 17, 2003

Confirmation No.: 9712

For: Silicon-Containing Layer
Deposition with Silicon
Compounds

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§
§ Group Art Unit: 1762

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§ Examiner: Bret P. Chen

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on July 18, 2005, with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
7/18/05 Date	Kris Z. Rhee Signature

PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/7729/KMT, for \$350.00 in fees for excess claims, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. **Amendments to the Claims** begin on page 4 of this paper. **Remarks** begin on page 15 of this paper.